

<b>Notice of References Cited</b>	Application/Control No. 10/584,626		Applicant(s)/Patent Under Reexamination NIWANO, KAZUHITO	
	Examiner Ryan C. Kavleski		Art Unit 2475	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0192308 A1	09-2004	Lee et al.	455/436
*	B	US-6,865,233 B1	03-2005	Eriksson et al.	375/261
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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